

**Workshop 5 : Manufacturing Equipment Technology /
Display Measurement and Analysis Technology**

W-5-1 09:00 - 10:10

Developing the Comprehensive Display Measurement Standard to Bring Accuracy, Proper Metrology, and Needed Measurements to the Display Industry
J. Miseli (Sun Microsystems, USA)

Coffee Break 10:10-10:30

W-5-2 10:30-11:40

Polarization Measurement Technology for LCD Performance Improvement
M. H. Smith (Axometrics, USA)

Lunch 11:40-13:10

W-5-3 13:10-14:10

Overview of UniPixel's TMOS New Display Technology
J. M. Sasian (Univ. of Arizona, USA)

W-5-4 14:10-15:10

Re-emerging Stepper Technologies for Display Markets
E. M. da Silveira (Azores Corp., USA)

Coffee Break 15:10-15:30

W-5-5 15:30-16:40

Repair Technology for LCD Manufacturing
G. H. Lee (LG Display Co., Ltd., Korea)